

PROCEEDINGS OF SPIE

Plasmonics V

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Takuo Tanaka
Editors

12–16 October 2020
Online Only, China

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SPIE

Volume 11557

Proceedings of SPIE 0277-786X, V. 11557

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in *Plasmonics V*, edited by Zheyu Fang, Takuo Tanaka, Proceedings of SPIE Vol. 11557 (SPIE, Bellingham, WA, 2020) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510639294

ISBN: 9781510639300 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) Fax +1 360 647 1445

SPIE.org

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